





## FACSIMILE TRANSMISSION COVER PAGE

Lawrence Livermore National Laboratory  
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**TO: ISSUE FEE**  
Commissioner for Patents  
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Total pages 3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Stefan Peter Hau-Riege  
Entitled: Method for Characterizing Mask Defects Using Image Reconstruction from  
X-Ray Diffraction Patterns

Application No.: 10/783,520

Filed: February 20, 2004

Examiner: Sang H. Nguyen

Attorney Docket No. IL-11154

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that the following papers are being facsimile transmitted to the U.S. Patent and Trademark Office on March 20, 2007.

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April Masluk

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